

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Applicant:

Wilf et al.

Serial No.: 10/574,546

Filed: 3 APRIL 2006

For: Methods and Systems For Determining The Reliability of Transactions

Group Art Unit:

Attorney Docket No.: 2876/18

Examiner:

Commissioner of Patents and Trademarks
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Sir:

Enclosed is PTO Form 1449 which lists citations which may be material to the patentability of the above-identified application.

These are being submitted in compliance with the duty of disclosure defined in 37 C.F.R. 1.56. The Examiner is requested to make these citations of official record in this application.

This Information Disclosure Statement Under 37 C.F.R. 1.56 is not to be construed as a representation that a search has been made, that additional matter which is material to the examination of this application does not exist, or that any one or more of these citations constitutes prior art.

Respectfully submitted,

~~Mark M. Friedman
Attorney for Applicant
Registration No. 33,883
Date: September 19, 2006~~



Form PTO-1449 (Modified)

Atty. Docket No.
2876/18Application No.
10/574,546INFORMATION DISCLOSURE CITATION
IN AN APPLICATION
(USE SEVERAL SHEETS IF NECESSARY)Applicant:
Wilf et alFiling Date:
April 3, 2006

Group Art Unit:

U.S. PATENT DOCUMENTS

	EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB- CLASS	FILING DATE
AA		003/0023541	1/2003	Black et al.			
AB		5757917	5/1998	Rose et al.			
AC		5826241	10/1998	Stein et al.			
AD							
AE							
AF							
AG							
AH							
AI							
AJ							
AK							

FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB- CLASS	TRANSLATION	
							YES	NO
AL		WOO3/017049	2/2003	PCT	G06Q 20/00			
AM		WO01/69549	9/2001	PCT	G06Q 20/00			
AN								
AO								
AP								
AQ								

OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)

AR Data Mining: Practical Machine Learning Tools and Techniques with Java Implementations by: Ian H. Witten, Eibe Frank, Morgan Kaufmann (Oct 1999)

EXAMINER

DATE CONSIDERED

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformation and not considered. Include copy of this form with next communication to applicant.